



2881/1/1  
DOCKET NO: VSEA 05-99

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Charles M. McKenna et al.  
Serial No: 09/602,059  
Confirmation No: 9493  
Filed: June 23, 2000  
For: ION IMPLANTER HAVING TWO-STAGE DECLARATION  
BEAMLINE  
Examiner: Mary A. El-Shammaa  
Art Unit: 2881

RECEIVED  
MAY 15 2003  
TECHNOLOGY CENTER 2881

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, Washington, D.C. 20231, on the 6<sup>th</sup> day of May, 2003.

*Cheryl A. Purcell*  
Cheryl Purcell

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Transmitted herewith are the following documents:

- ☒ Amendment
- ☒ Petition for Extension of Time
- ☒ Return Receipt Postcard

If any additional fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited. A duplicate of this sheet is enclosed.

Respectfully submitted,  
*Charles M. McKenna et al., Applicants*

By: *Mark A. Superko*  
Mark A. Superko, Reg. No. 34,027  
Varian Semiconductor Equipment  
Associates, Inc.  
35 Dory Rd.  
Gloucester, Massachusetts 01930-2297  
Telephone: (978) 282-5915

Docket No. VSEA 05-99